## Docket Number (Optional) **Application Number FORM PTO-1449** 10/632,522 83377.0008 INFORMATION DISCLOSURE CHATTON **Applicant** HEE, et al. IN AN APPLICATION (Use several sheets if necess **Group Art Unit** Filing Date August 1, 2003 1773 U.S PATENT DOCUMENTS FILING DATE IF **EXAMINER SUBCLASS** DATE NAME CLASS **DOCUMENT NUMBER** APPROPRIATE INITIAL 03/05/96 KITAKAMI, et al. 5,496,620 428 212 05/14/02 IWASAKI, et al. 6,387,476 12/07/99 5,998,048 JIN, et al. 11/19/02 IWASAKI, et al. 6,483,741 02/27/03 CHEN, et al. 094TM 2003/0039863 03/13/03 DAUGHTON, et al. 2003/0048676 200 VI 12/31/02 HASEGAWA, et al. 6,500,570 1092 FOREIGN PATENT DOCUMENTS **Translation** DATE COUNTRY -**CLASS SUBCLASS DOCUMENT NUMBER** YES OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) WANG, et al., "Approaches to Tilted Magnetic Recording for Extremely High Areal Density" IEEE Transactions on Magnetics, July 2003, Vol. 39, Issue 4, Part 1, pgs. 1930-1935 MATSUBARA, et al., "Magnetization Behavior In Exchange-Coupled Co/TbFeCo Films", IEEE Transactions on Magnetics, Sep. 1990, Vol. 26, Issue 5, pgs. 1906-1908

EXAMINÈR	Hellelle	DATE CONSIDERED 3 13 00	
	71 -0.		

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.